



648.42568VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: G. MIYA et al

Serial No.: 10/779,742

Filed: February 18, 2004

For: Plasma Processing Method

Art Unit: 1763

Examiner: P. Hassanzadeh

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 17, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated September 17, 2004. The amendments are listed below and set forth on the following pages.

Amendments to the Claims;

Amendments to the Abstract:

Amendments to the Drawings describing changes to drawing shown in the Appendix;

Remarks are included following the amendments; and

An Appendix including amended drawing figures is attached following the Remarks.